

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: To Be Assigned

Examiner: To Be Assigned

In re PATENT APPLICATION of:

Applicant(s) : Toshikazu MIZUKOSHI )

Appln. No. : To Be Assigned )

Filed : August 7, 2003 )

For : METHOD OF FABRICATING A  
SEMICONDUCTOR DEVICE HAVING )  
TRENCHES )

Atty. Dkt. : OKI 361 )

**INFORMATION  
DISCLOSURE  
STATEMENT**

August 7, 2003

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

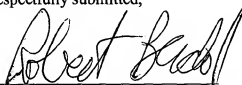
Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(b)(1).

Attached are copies of four Japanese publications and one article. Any relevance of the Japanese publications or article can be gleaned from the attached English-language Abstracts or translations. The publications and article are listed on the attached Form PTO-1449. Also listed on the Form PTO-1449 for consideration are three U.S. patents. Any relevance of these U.S. patents is self-evident.

Since this Information Disclosure Statement is being filed with the application, no certification or fee is required, and the requirements of 37 C.F.R. §§1.97 and 1.98 are deemed to be fully met as to the document submitted. Consideration of the submitted and listed documents is respectfully requested.

Respectfully submitted,



Robert H. Berdo, Jr. (Reg. No. 38,075)  
RABIN & BERDO, P.C.  
CUSTOMER NO. 23995  
(202) 371-8976  
(202) 408-0924 fax

August 7, 2003

Date

RHB:tz

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|--|----|--|----------|---------------------|-----------------|-----------------|-------------|
| <b>FORM PTO-1449</b><br><b>INFORMATION DISCLOSURE STATEMENT</b>  |    |  |          | Atty Docket         |                 | Application No. |             |
|  |    |  |          | OKI 361             |                 | To Be Assigned  |             |
|  |    |  |          | Applicant           |                 |                 |             |
|  |    |  |          | Toshikazu MIZUKOSHI |                 |                 |             |
|  |    |  |          | Filing Date         |                 | Group Unit      |             |
|  |    |  |          | August 7, 2003      |                 | To Be Assigned  |             |
| <b>U.S. PATENT DOCUMENTS</b>   |    |  |          |                     |                 |                 |             |
| Examiner Initial   |    | Document Number  | Date     | Name                | Class           | Sub-Class       | Filing Date |
|  | AA | 6,268,629  | 07/31/01 | Noguchi             |                 |                 |             |
|  | AB | 6,245,684  | 06/12/01 | Zhao et al.         |                 |                 |             |
|  | AC | 6,051,479  | 04/18/00 | Hong                |                 |                 |             |
|  | AD |  |          |                     |                 |                 |             |
|  | AE |  |          |                     |                 |                 |             |
|  | AF |  |          |                     |                 |                 |             |
|  | AG |  |          |                     |                 |                 |             |
|  | AH |  |          |                     |                 |                 |             |
|  | AI |  |          |                     |                 |                 |             |
|  | AJ |  |          |                     |                 |                 |             |
| <b>FOREIGN PATENT DOCUMENTS</b>  |    |  |          |                     |                 |                 |             |
|  |    | Document Number  | Date     | Country             | Class           | Sub-Class       | Translation |
|  | AK | 2001-244327  | 09/07/01 | Japan               |                 |                 | Abstract    |
|  | AL | 2000-101071  | 04/07/00 | Japan               |                 |                 | Abstract    |
|  | AM | 11-102961  | 04/13/99 | Japan               |                 |                 | Abstract    |
|  | AN | 10-223747  | 08/21/98 | Japan               |                 |                 | Abstract    |
| <b>OTHER (Including Author, Title, Date, Pertinent Pages, etc.)</b>  |    |  |          |                     |                 |                 |             |
|  | AO | 1991.3, Semiconductor World, p128-p131, and translation thereof. |          |                     |                 |                 |             |
|  | AP |  |          |                     |                 |                 |             |
|  | AQ |  |          |                     |                 |                 |             |
|  | AR |  |          |                     |                 |                 |             |
| Examiner   |    |  |          |                     | Date Considered |                 |             |
| EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant. |    |  |          |                     |                 |                 |             |